



#4110
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In re Application of

Yuegang Zhang

Serial No.: 09/665,679

Group Art Unit: 1754

Filed: September 20, 2000

Examiner: Stuart L. Hendrickson

For: MANUFACTURING METHOD OF CARBON NANOTUBES AND LASER
IRRADIATION TARGET FOR THE MANUFACTURE THEREOF

Honorable Assistant Commissioner of Patents
Washington, D.C. 20231

**RESPONSE TO FIRST OFFICE ACTION AND RESTRICTION
REQUIREMENT**

Sir:

In response to the Office Action dated February 25, 2002, please consider the
following:

REMARKS

2374

In response to the Examiner's restriction requirement, Applicant hereby elects the
invention of Group II (e.g., drawn to a carbon material as defined by claims 13-18), without
traverse. Applicant reserves the opportunity to file a Divisional Application for the non-
elected invention later.

Further, Applicant respectfully requests the Examiner's acknowledgment of the
priority document filed on September 20, 2000.

Early, favorable prosecution on the merits is respectfully requested.

Should the Examiner find the application to be other than in condition for allowance,
the Examiner is requested to contact the undersigned at the local telephone number listed
below to discuss any other changes deemed necessary in a telephonic or personal interview.